

Notice of References Cited	Application/Control No. 10/809,942	Applicant(s)/Patent Under Reexamination CARRIERE ET AL.	
	Examiner Alexander G. Ghyska	Art Unit 2812	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,271,133	08-2001	Lim et al.	438/683
*	B	US-5,352,631	10-1994	Sitaram et al.	438/300
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Tavel et al (Totally Silicided CoSi2 Polysilicon) IEEE, pgs 37.5.1-37.5.5
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

Notice of References Cited

Alex Ghyska 12/26/05